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U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

10A15

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10068005	02/08/2002	118		1763	<i>[Signature]</i>

**\*\*APPLICANTS:** Jung Hyo-Sang; *Red get*

**\*\*CONTINUING DATA VERIFIED:**

**\*\* FOREIGN APPLICATIONS VERIFIED:**  
REPUBLIC OF KOREA 2001-8175 02/19/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials		ATTORNEY DOCKET NO 262/011
TITLE : Vacuum apparatus of ion implantation system and evacuation method		

U.S. DEPT. OF COMM/PAT & TM-PTO-436L (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for O.G.
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
		Application Examiner	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>PREPARED FOR ISSUE</b>	
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